
 APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/692,152		OFGS File No. P/2041-68			
		Applicant Hiroyuki UNO et al					
		Filing Date October 22, 2003		Group Art Unit 2642			
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
/WK/	2001-34394	02-2001	Japan				X
/WK/	6-261376		Japan				X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
/WK/		Office Action issued by Japanese Patent Office on August 15, 2006 in connection with					
		corresponding Japanese application no. 2002-307737					
/WK/		English translation of Japanese Office Action dated August 15, 2006					
		issued in connection with corresponding Japanese application no. 2002-307737					
Examiner /Wesley Kim/		Date Considered 05/03/2007					
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						Yes	No
/WK/	2001-34398	02-2001	Japan				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
/WK/		Office Action issued by Japanese Patent Office on May 16, 2006 in connection with					
		corresponding Japanese application no. 2002-307737					
/WK/		English translation of Japanese Office Action dated May 16, 2006					
		issued in connection with corresponding Japanese application no. 2002-307737					
Examiner /Wesley Kim/		Date Considered 05/03/2007					
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FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation
						Yes No
/WK/	2001-61178	03-2001	Japan			X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
/WK/		Office Action issued by Japanese Patent Office on October 31, 2006 in connection with				
		corresponding Japanese application no. 2002-307737				
/WK/		English translation of Japanese Office Action dated October 31, 2006				
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